INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary) U.S. Patent Documents *Examiner Initial Document Number Date Name AA AB AB AC AD AC AD AE AF AG AG AH AH AI AI	MIC-M074 Applicant(s) Shekar Mallil Filing Date Herewith Class	Subclass	Group Not yet know Group Not yet know Filing I If Appro	vn Date
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